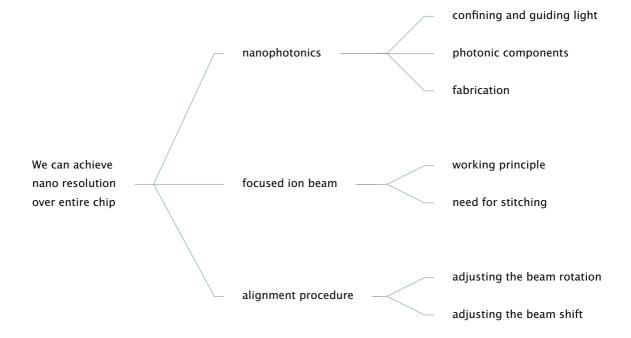
Marie's outline

Main message Main points Subpoints



From a 10-minute PhD-day presentation on Automated alignment procedure for stitching with a focused ion beam, by Marie Verbist (Universiteit Gent)